Attorney Docket No.: IB-1830

WHAT IS CLAIMED IS:

1. A method of growing a CdS/ZnS graded shell, comprising:

providing a core,

combining the core with at least one surfactant,

heating the mixture,

combining the mixture with a CdS/ZnS stock solution,

wherein the core comprises a semiconductor material, and

graded core/shell nanorods are produced.

2. The method of claim 1, wherein:

the core is rod shaped.

3. The method of claim 2, wherein:

the core comprises CdSe.

4. The method of growing a CdS/ZnS graded shell of claim 1, wherein:

the mixture is heated to a temperature between 100-360 °C.

5. The method of growing a CdS/ZnS graded shell of claim 1, wherein:

the mixture is heated to a temperature of 160°C.

6. The method of growing a CdS/ZnS graded shell of claim 1, wherein:

the core is combined with only one surfactant.

7. The method of growing a CdS/ZnS graded shell of claim 1, wherein:

the surfactant is chosen from the group consisting of TOPO, TBP, HDA, HPA and

TDPA.

8. The method of growing a CdS/ZnS graded shell of claim 1, wherein:

the mixture is kept at a temperature of approximately 160° for between 5 minutes and

24 hours after combining the CdS/ZnS stock solution.

9. The method of growing a CdS/ZnS graded shell of claim 8, wherein:

- the mixture is kept at a temperature of 160°C for 10 minutes after combining the CdS/ZnS stock solution.
- 10. The method of growing a CdS/ZnS graded shell of claim 1, wherein: the core is a shaped nanorod.
- 11. The method of growing a CdS/ZnS graded shell of claim 10, wherein: the core has a tetrapod shape.
- 12. The method of growing a CdS/ZnS graded shell of claim 1, wherein: the graded core/shell nanorods are photochemically annealed.
- 13. The method of growing a CdS/ZnS graded shell of claim 12, wherein: the annealing is done using an Ar+ laser.
- 14. A method of growing a CdS/ZnS graded shell, comprising:

 providing a core/surfactant mixture,

 heating the mixture,

 combining the mixture with a CdS/ZnS stock solution.
- 15. The method of growing a CdS/ZnS graded shell of claim 14, wherein: the core is rod shaped.
- 16. The method of growing a CdS/ZnS graded shell of claim 15, wherein: the core comprises CdSe.
- 17. The method of growing a CdS/ZnS graded shell of claim 14, wherein: the mixture is heated to a temperature between 100-360 °C.
- 18. The method of growing a CdS/ZnS graded shell of claim 14, wherein: the mixture is heated to a temperature of 160°C.
- 19. The method of growing a CdS/ZnS graded shell of claim 14, wherein: the core/surfactant mixture contains only one surfactant.
- 20. The method of growing a CdS/ZnS graded shell of claim 14, wherein:

the surfactant is chosen from the group consisting of TOPO, TBP, HDA, HPA and TDPA.

- 21. The method of growing a CdS/ZnS graded shell of claim 14, wherein:
 the mixture is kept at a temperature of approximately 160° for between 5 minutes and
 24 hours after combining the CdS/ZnS stock solution.
- 22. The method of growing a CdS/ZnS graded shell of claim 21, wherein: the mixture is kept at a temperature of 160°C for 10 minutes after combining the CdS/ZnS stock solution.
- 23. The method of growing a CdS/ZnS graded shell of claim 14, wherein: the core is a shaped nanorod.
- 24. The method of growing a CdS/ZnS graded shell of claim 23, wherein: the core has a tetrapod shape.
- 25. A method of growing a graded core/shell semiconductor nanorod, comprising:

 providing a semiconductor nanorod core,

 combining the core with at least one surfactant,

 heating the surfactant/core mixture,

 combining the mixture with a solution,

 wherein said solution comprises semiconductor precursors in molar ratio sufficient to

 cause the growth of a graded semiconductor shell on the core.
- 26. The method of growing a graded core/shell semiconductor nanorod of claim 25, wherein:
 the semiconductor nanorod core comprises a semiconductor material selected from the group consisting of Group II-VI, Group III-V and Group IV semiconductors.
- 27. The method of growing a graded core/shell semiconductor nanorod of claim 25, wherein:

the core is rod shaped.

28. The method of growing a graded core/shell semiconductor nanorod of claim 25, wherein:

the core comprises CdSe.

TDPA.

29. The method of growing a graded core/shell semiconductor nanorod of claim 25, wherein:

the mixture is heated to a temperature between 100-360 °C.

30. The method of growing a graded core/shell semiconductor nanorod of claim 29, wherein:

the mixture is heated to a temperature of 160°C.

31. The method of growing a graded core/shell semiconductor nanorod of claim 25, wherein:

only one surfactant is combined with the core.

32. The method of growing a graded core/shell semiconductor nanorod of claim 25, wherein:
the surfactant is chosen from the group consisting of TOPO, TBP, HDA, HPA and

33. The method of growing a graded core/shell semiconductor nanorod of claim 25, wherein:

the mixture is kept at a temperature of approximately 160° for between 5 minutes and 24 hours after combining the solution.

34. The method of growing a graded core/shell semiconductor nanorod of claim 33, wherein:

the mixture is kept at a temperature of 160°C for 10 minutes after combining the solution.

- 35. The method of growing a graded core/shell semiconductor nanorod 25, wherein: the core is a shaped nanorod.
- 36. The method of growing a graded core/shell semiconductor nanorod of claim 35, wherein:

the core has a tetrapod shape.

37. The method of growing a graded core/shell semiconductor nanorod of claim 25, wherein:

the graded core/shell nanorod is photochemically annealed.

38. The method of growing a graded core/shell semiconductor nanorod of claim 37, wherein:

the annealing is done using an Ar+ laser.

39. The method of growing a graded core/shell semiconductor nanorod of claim 25, wherein:

the core comprises CdSe and the graded shell comprises CdS/ZnS.

40. A graded core/shell semiconductor nanorod comprising:

at least a first segment comprising:

a core comprising a Group II-VI, Group III-V or a Group IV semiconductor,

a graded shell overlying the core,

wherein the graded shell comprises at least two monolayers,

wherein the at least two monolayers each independently comprise a Group II-VI, Group III-V or a Group IV semiconductor.

41. The graded core/shell semiconductor nanorod of claim 40, wherein:

the graded shell has at least three monolayers, and

the monolayer closest to the core comprises a first semiconductor material, and

the outermost monolayer comprises a second semiconductor material, wherein

- between the monolayer closest to the core and the outermost monolayer there exists a concentration gradient of the first and second semiconductor material.
- 42. The graded core/shell semiconductor nanorod of claim 40, wherein: the number of monolayers is between two and eight.
- 43. The graded core/shell semiconductor nanorod of claim 42, wherein: the number of monolayer is between 2 and 6.
- 44. The graded core/shell semiconductor nanorod of claim 40, wherein: there is a tail extending longitudinally from the core.
- 45. The graded core/shell semiconductor nanorod of claim 40, wherein: the core comprises CdSe and the graded core/shell comprises CdS/ZnS.
- 46. The graded core/shell semiconductor nanorod of claim 40, wherein:
 there is joined to the first segment a second segment comprising:
 a core comprising a Group II-VI, Group III-V or a Group IV semiconductor,
 a graded shell overlying the core,
 wherein the graded shell comprises at least two monolayers,
 wherein the at least two monolayers each independently comprise a Group II-VI,
 Group III-V or a Group IV semiconductor.
- 47. The graded core/shell semiconductor nanorod of claim 46, wherein:

 the second segment core comprises CdSe and the second segment graded shell
 monolayers comprise, in order, CdS/ZnS.
- 48. The graded core/shell semiconductor nanorod of claim 47, wherein: the first and the second segments have different cross sectional areas.
- 49. The graded core/shell semiconductor nanorod of claim 47, wherein: there is a third segment joined to the second segment.
- 50. The graded core/shell semiconductor nanorod of claim 49, wherein:

the first, second and third segments have different cross sectional areas.

- 51. A nanorod barcode, comprising:
 - a first segment of a first material; and
 a second segment of a second material joined longitudinally to said first segment;
 wherein at least one of the first and second segments is capable of generating
- 52. The nanorod barcode of claim 51, wherein:

emission in response to excitation energy.

said first and second segments comprise a nanorod core, and said first and second segment cores independently comprise either a semiconductor material selected from the group consisting of Group II-VI, Group III-V and Group IV semiconductors or a metal selected from the group consisting of transition metals, oxides and nitrides thereof.

- 53. The nanorod barcode of claim 52, wherein:
 - said first and second segment cores independently comprise a semiconductor material selected from the group consisting of Group II-VI, Group III-V and Group IV semiconductors.
- 54. The nanorod barcode of claim 52, wherein:

said first segment core comprises a metal selected from the group consisting of transition metals, oxides and nitrides thereof, and said second segment comprises a semiconductor material selected from the group consisting of Group II-VI, Group III-V and Group IV semiconductors.

55. The nanorod barcode of claim 52, further comprising:

a third segment connected longitudinally to said first segment core, and said third segment core comprising a semiconductor material selected from the group consisting of Group II-VI, Group III-V and Group IV semiconductors.

- 56. The nanorod barcode of claim 55, wherein: said second and third segments have different cross sectional areas.
- 57. The nanorod barcode of claim 55, wherein:
 said first segment core comprises Co, and said second and third segment cores
 comprise CdSe.
- 58. The nanorod barcode of claim 53, wherein: said first and second segments have different cross sectional areas.
- 59. The nanorod barcode of claim 58, wherein:

 at least one of said first and second segment cores have a graded shell overlying the core.
- 60. The nanorod barcode of claim 58, wherein:

 both segment cores have a graded shell overlying said cores.
- 61. The nanorod barcode of claim 53, wherein:

 there is a third segment joined longitudinally to said second segment, and
 said third segment comprises a semiconductor material selected from the group
 consisting of Group II-VI, Group III-V and Group IV semiconductors.
- 62. The nanorod barcode of claim 61, wherein:

 at least one of said first and second and third segment cores have a graded shell overlying the core.
- 63. The nanorod barcode of claim 62, wherein:
 all segment cores have a graded shell overlying the cores.
- 64. The nanorod barcode of claim 55, wherein: said first, second and third segments have different cross sectional areas.
- 65. A method of using a nanorod barcode to identify an element, comprising:

labeling at least one identifiable element with at least one nanorod barcode as claimed in claim 51.